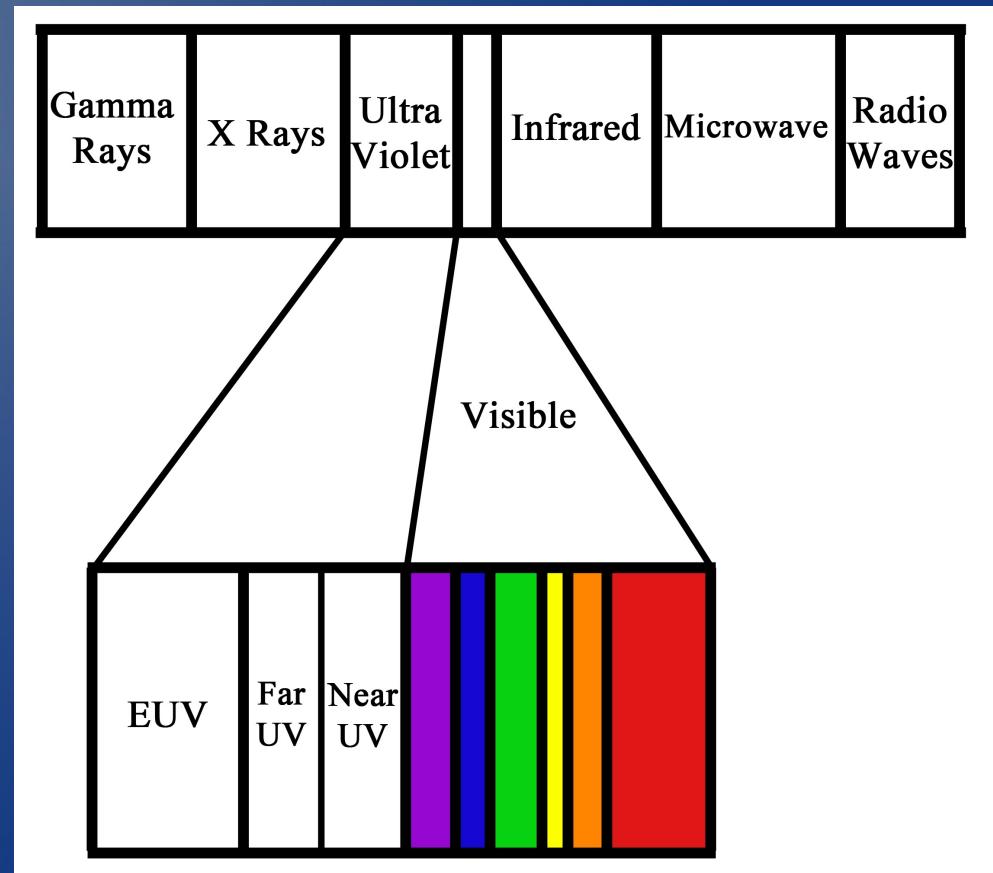


Using EUV Reflection to Understand Thin Film Surfaces

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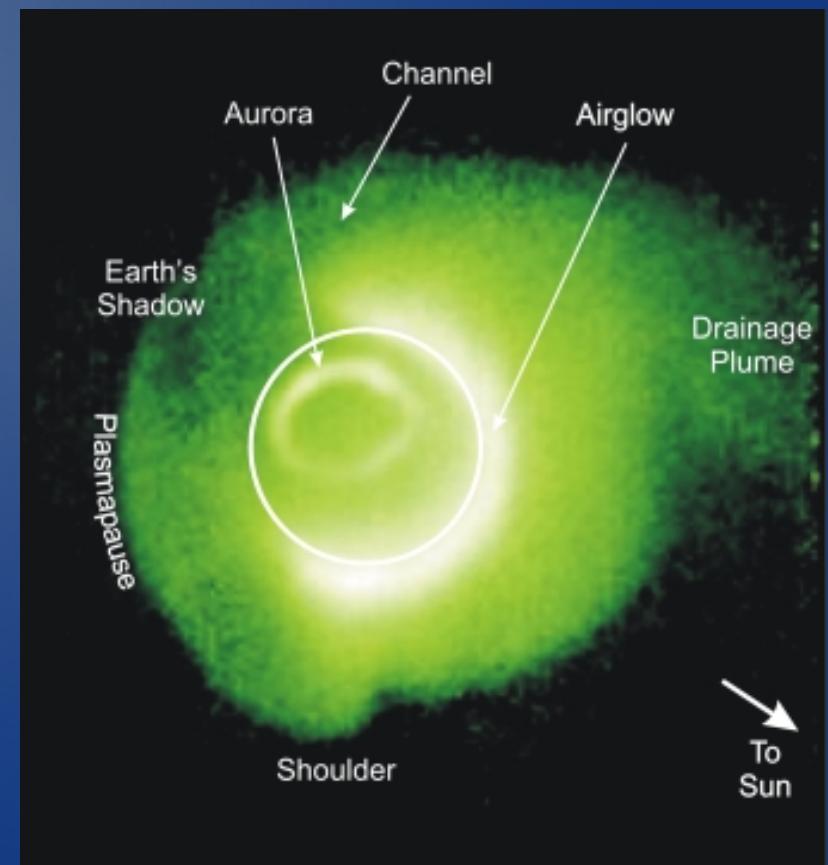
Background

- EUV
 - We use wavelengths of 5nm to 50nm
 - EUV light is very sensitive to absorption in most materials



Background

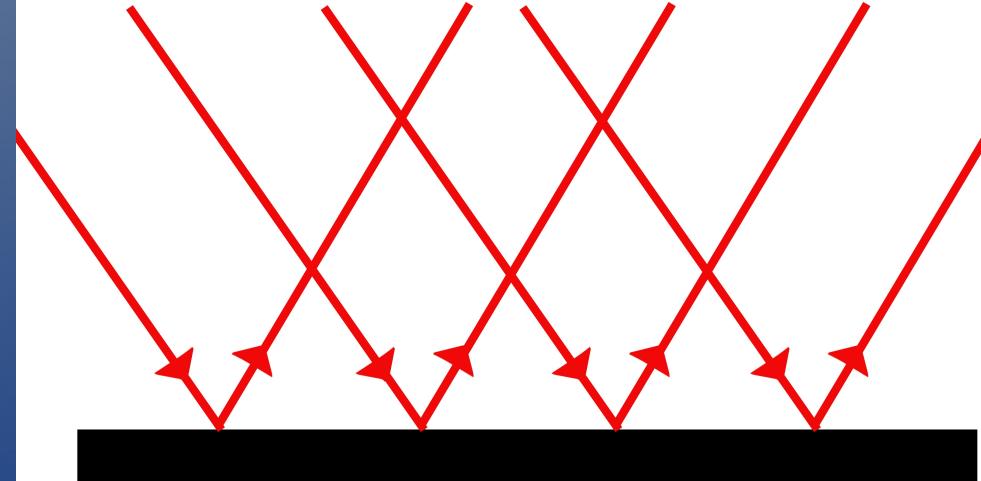
- EUV
 - We use wavelengths of 5nm to 50nm
 - EUV light is very sensitive to absorption in most materials
- Applications
 - Astronomy
 - EUV Lithography
 - Microscopy
 - Etc.



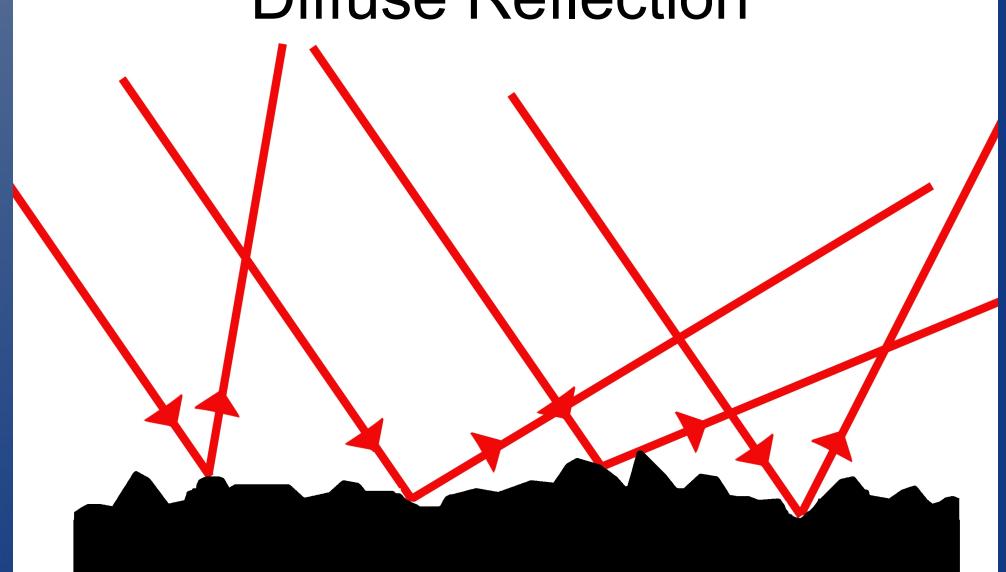
Background

- Diffuse Reflection
 - EUV light is sensitive to deviations in the surface roughness that are comparable to the wavelength of EUV light.

Specular Reflection

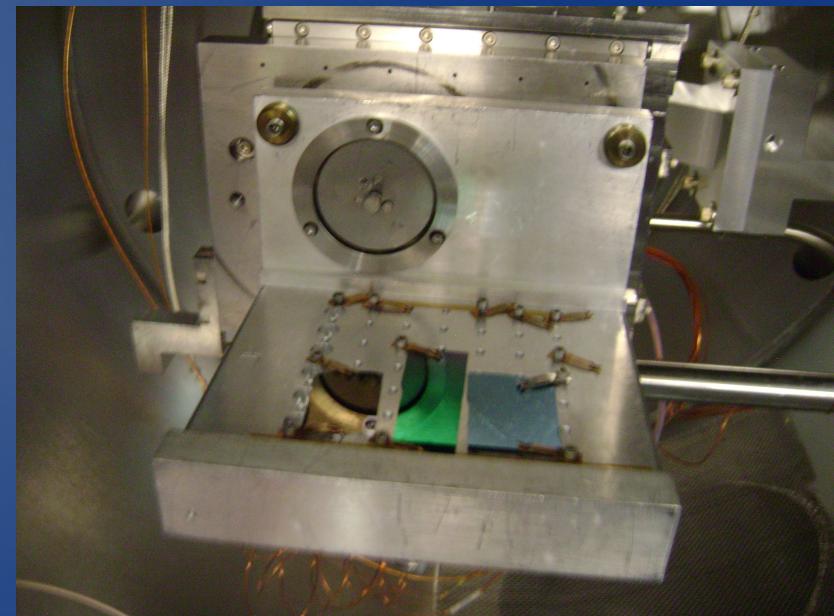


Diffuse Reflection



Goal/Method

- Goal
 - Learn something about thin film surface features.
- Method
 - Calculation/AFM
 - Reflection Measurements

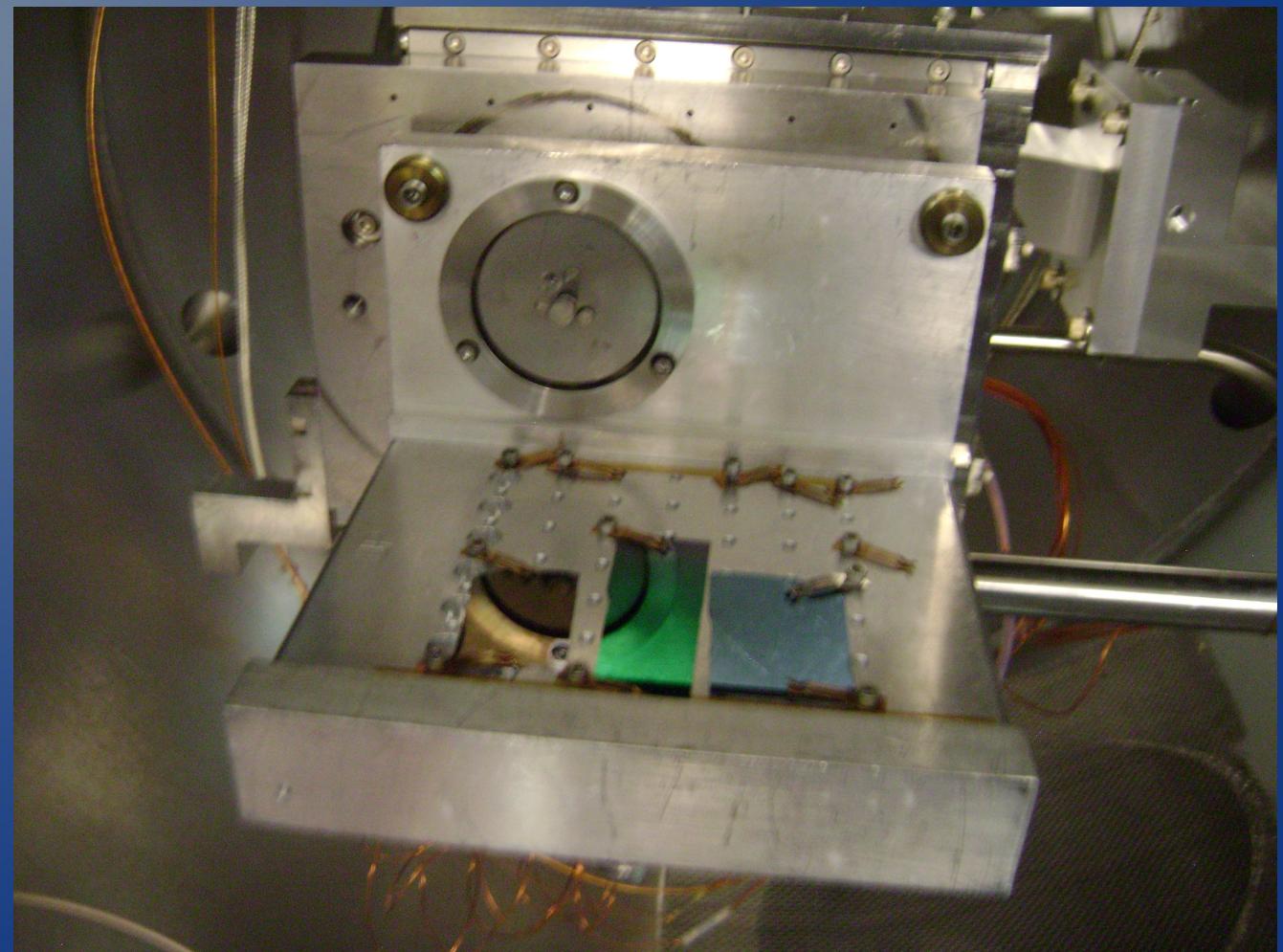


Samples

- Taken on two UO_3 Thin Films

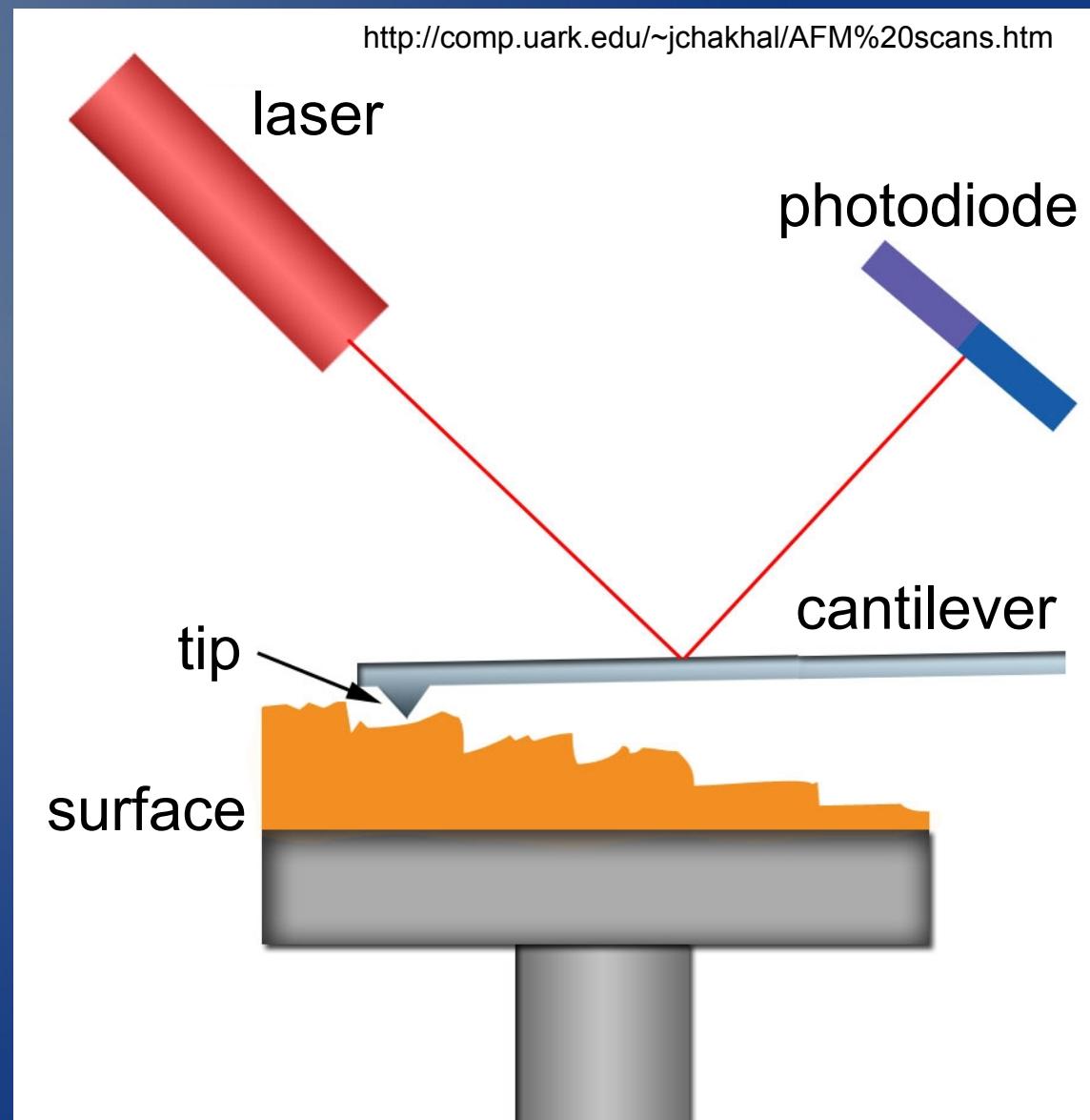
44nm Thick

412nm Thick

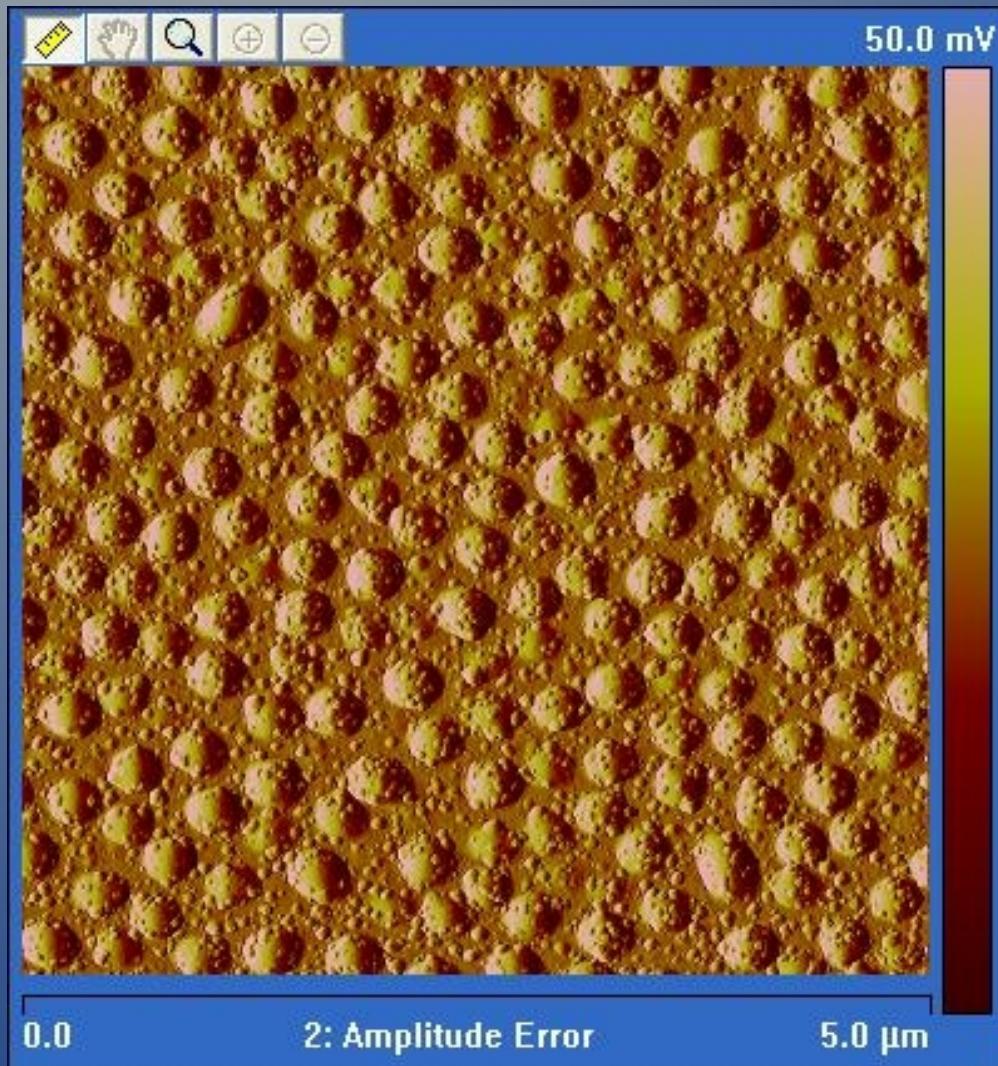


AFM

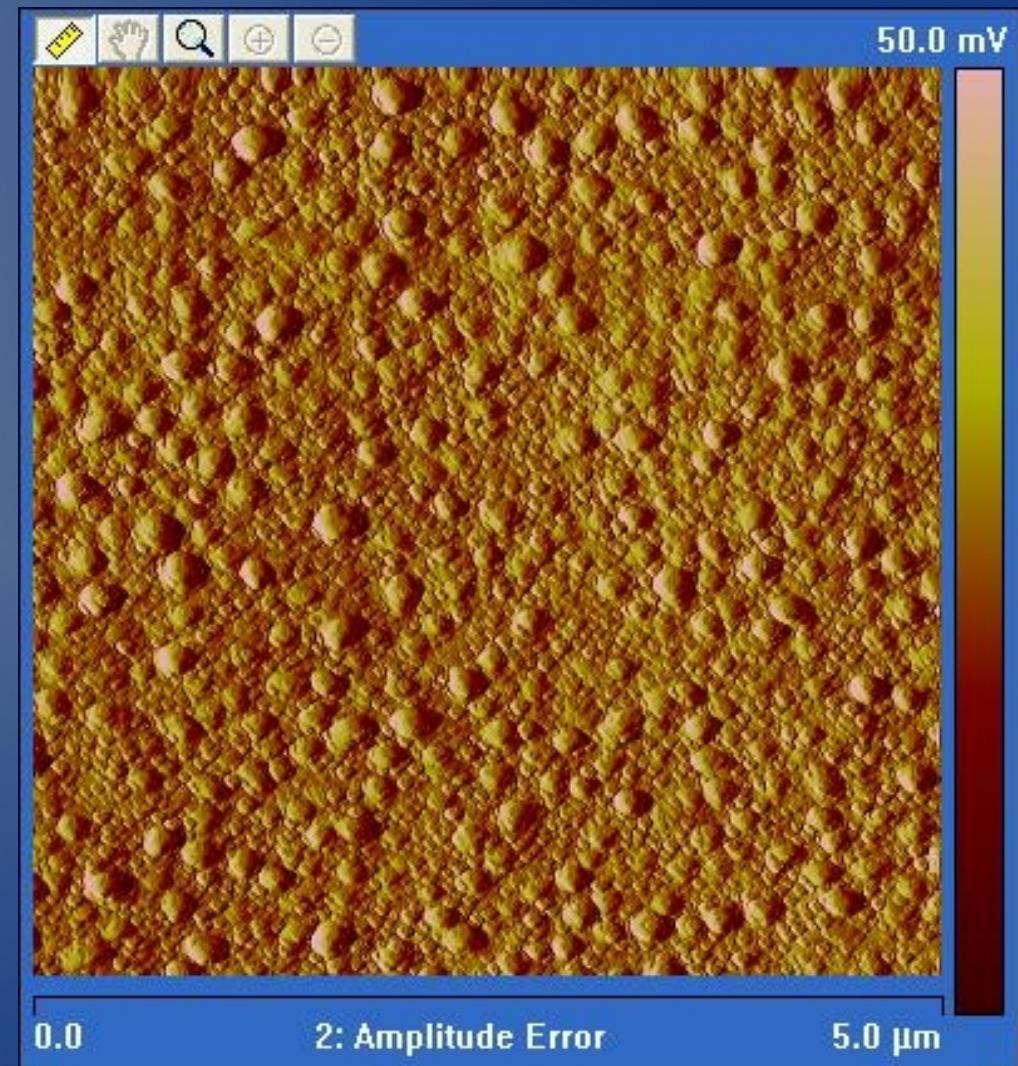
- Tip is bounced across the surface.
- Laser detects movement of the cantilever and height is recorded.



AFM



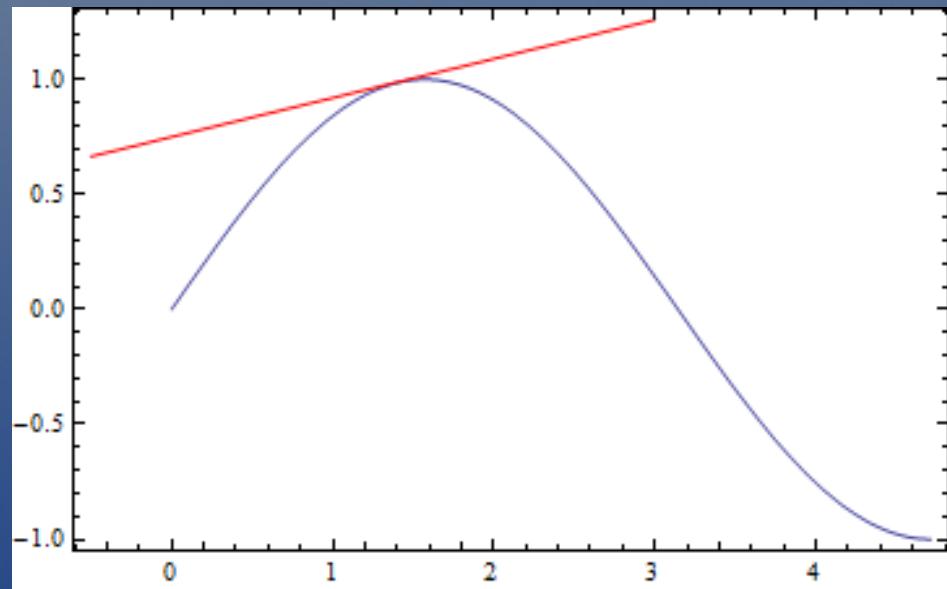
Thickness: 44nm
RMS height: 16.8nm



Thickness: 412nm
RMS height: 9.39nm

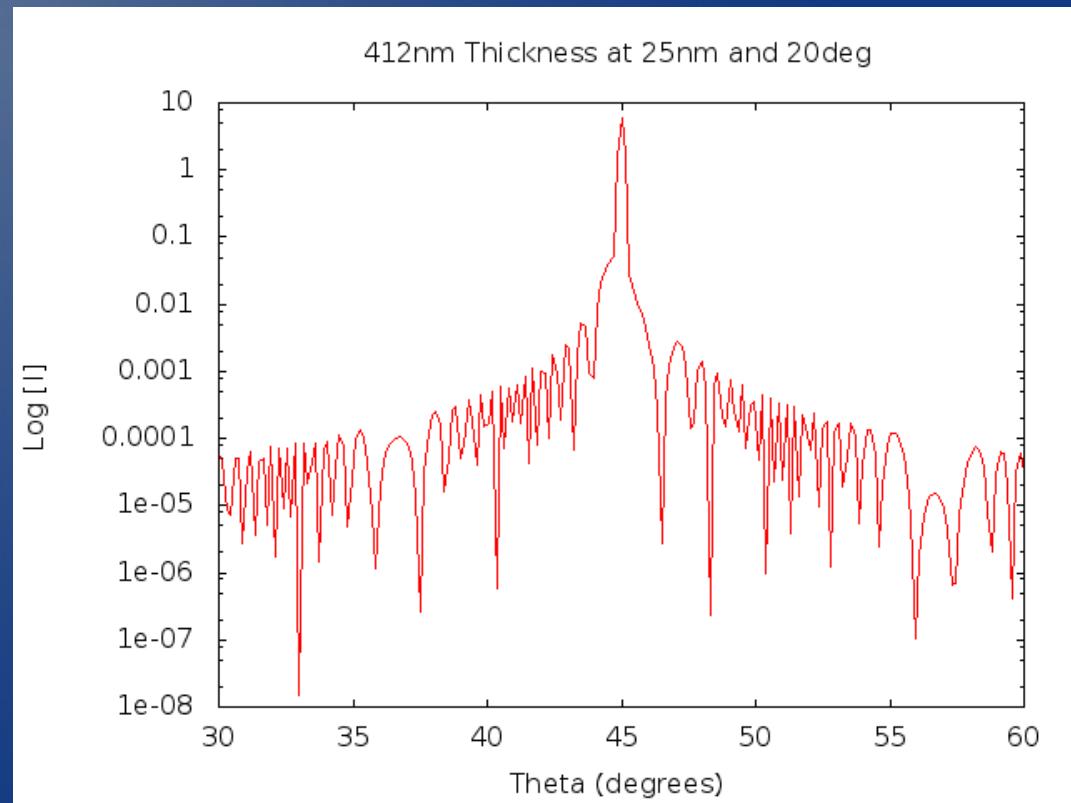
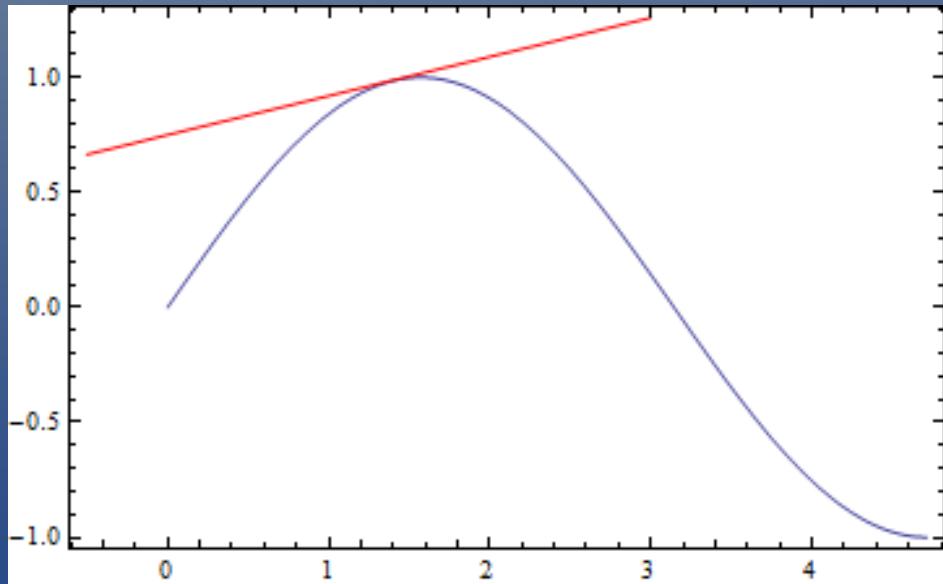
Physical Optics Calculation

- Kirchhoff approximation



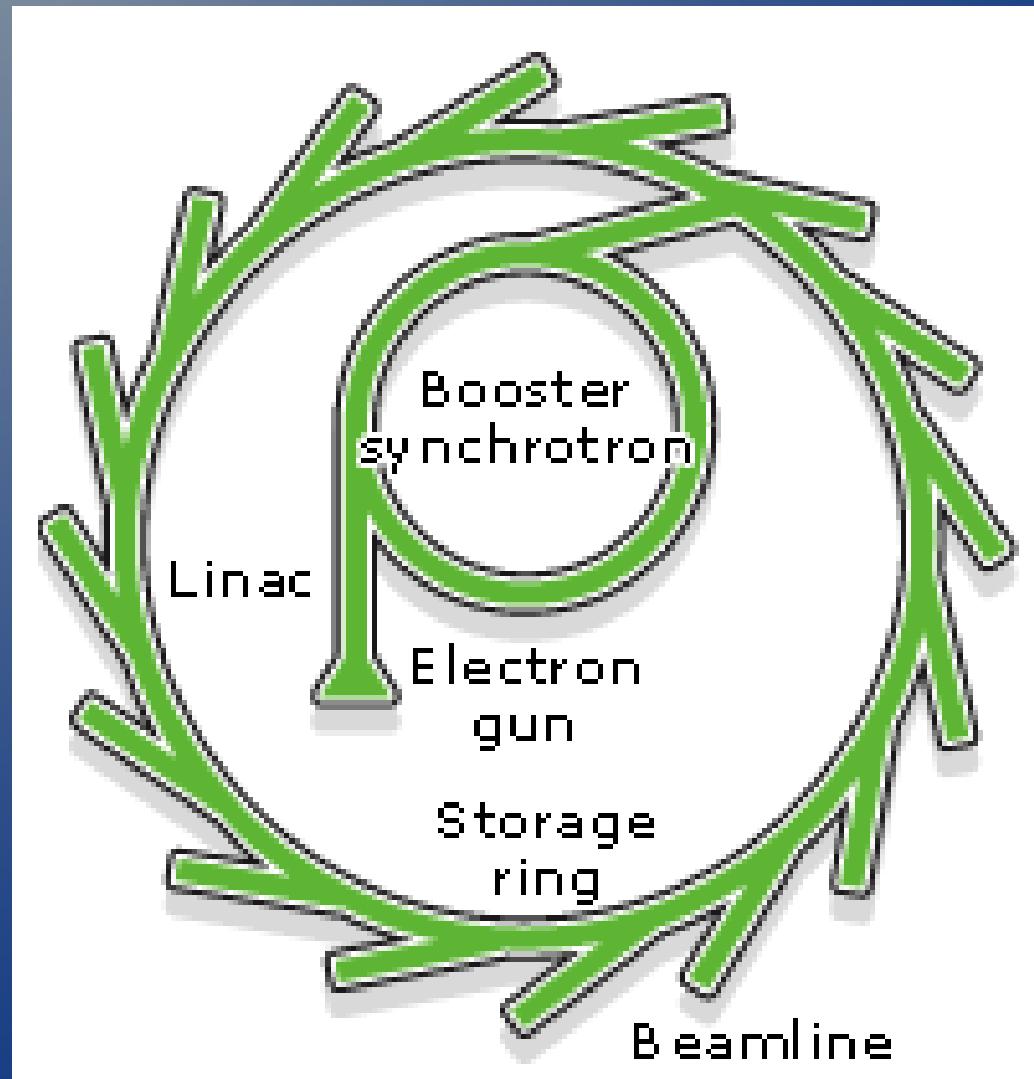
Physical Optics Calculation

- Kirchhoff approximation
- Use Maxwell's equations to calculate the current induced by incident light
- Calculate radiation in the far field

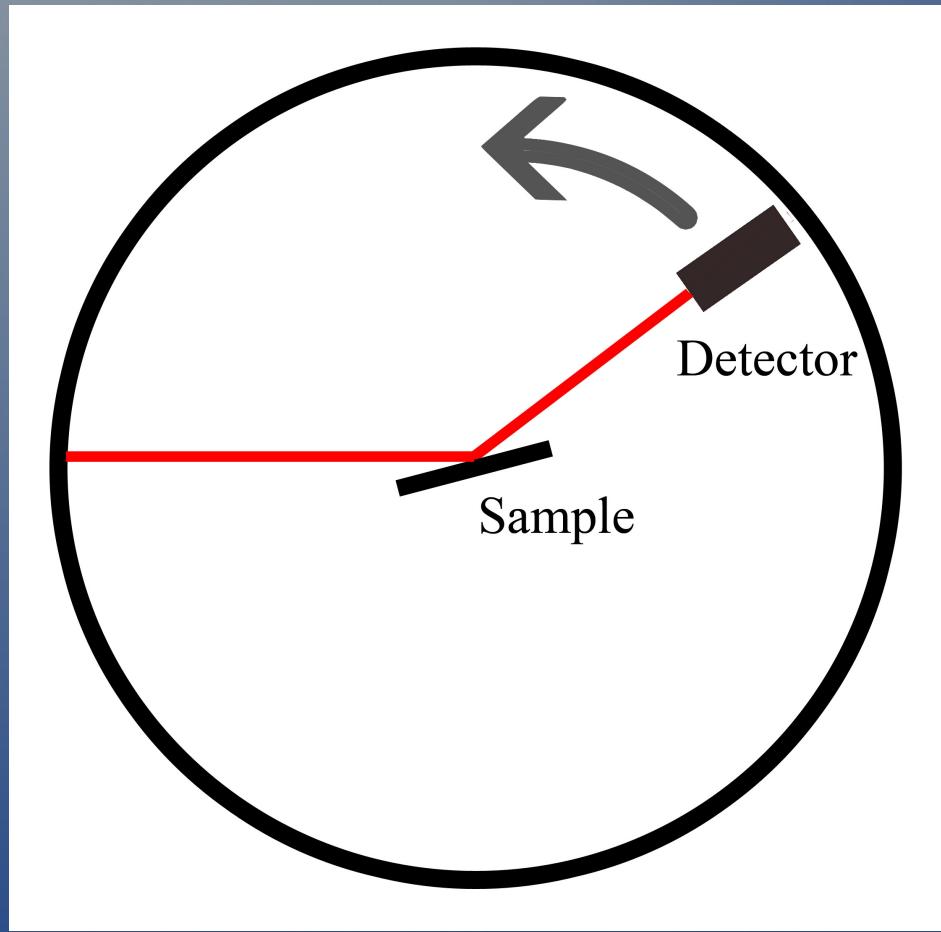


Reflection at The ALS

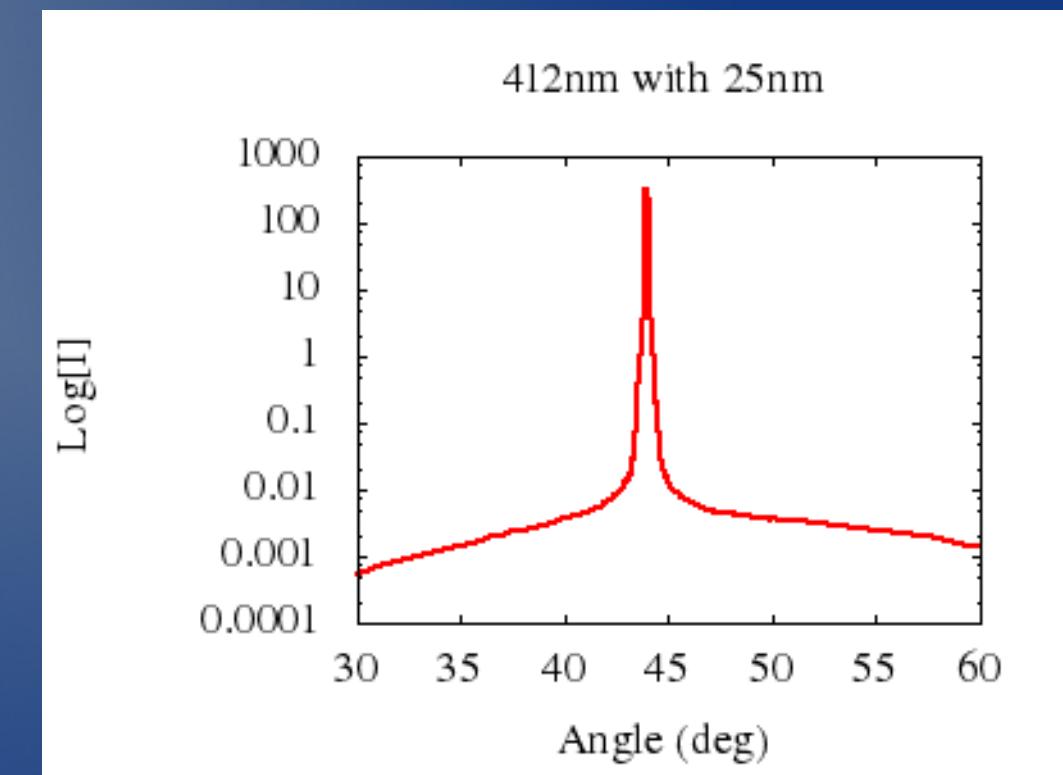
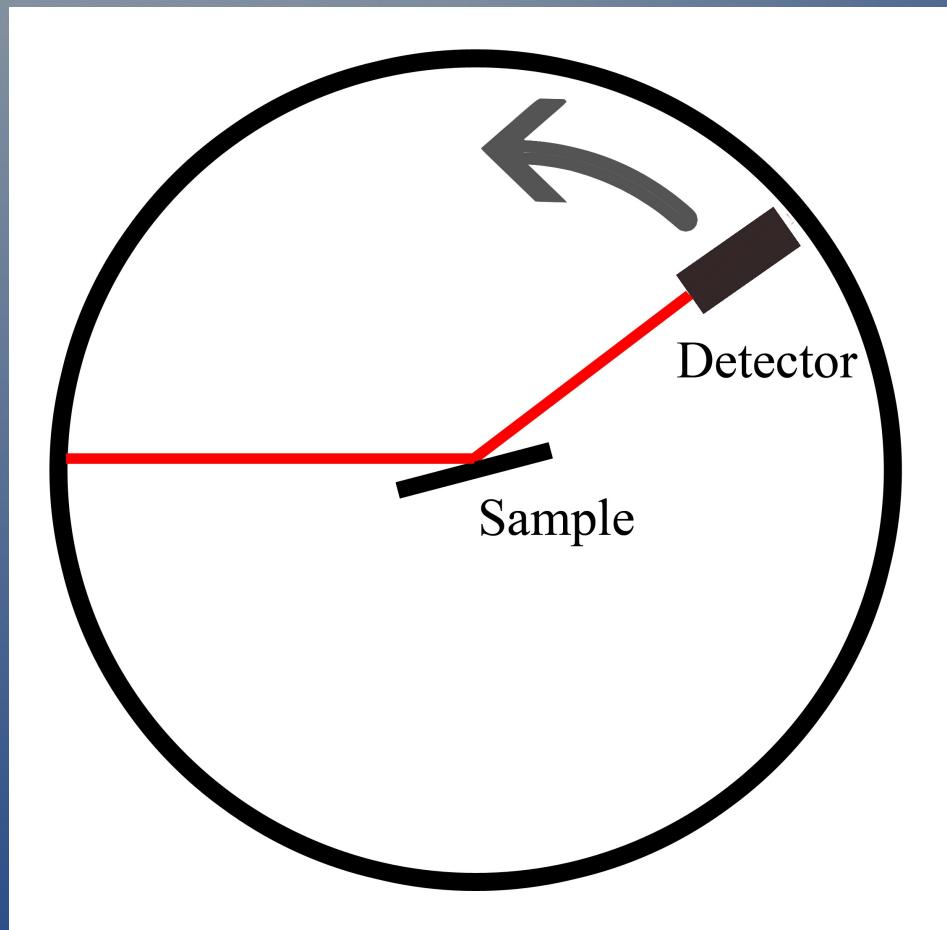
- Synchrotron Radiation



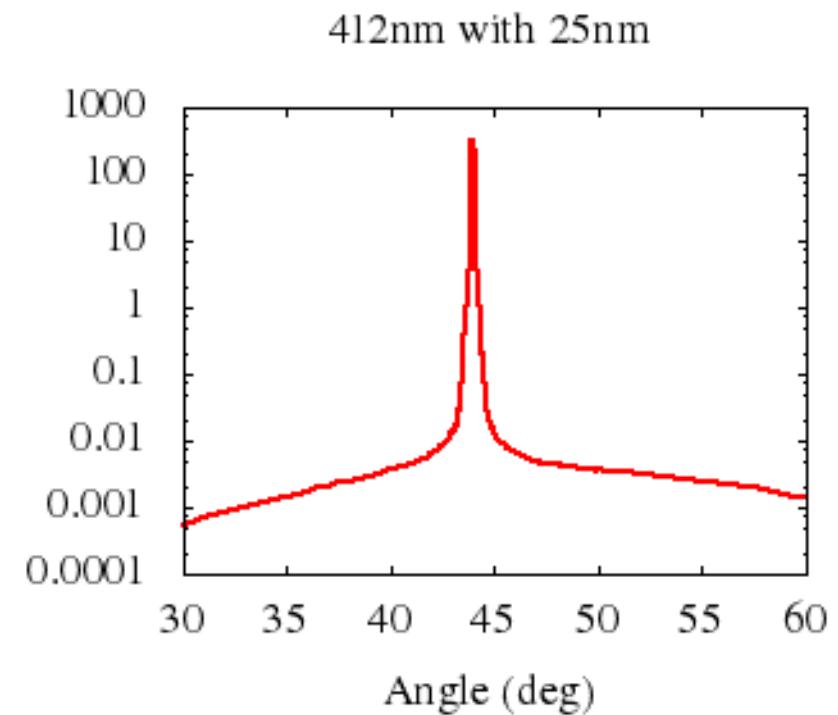
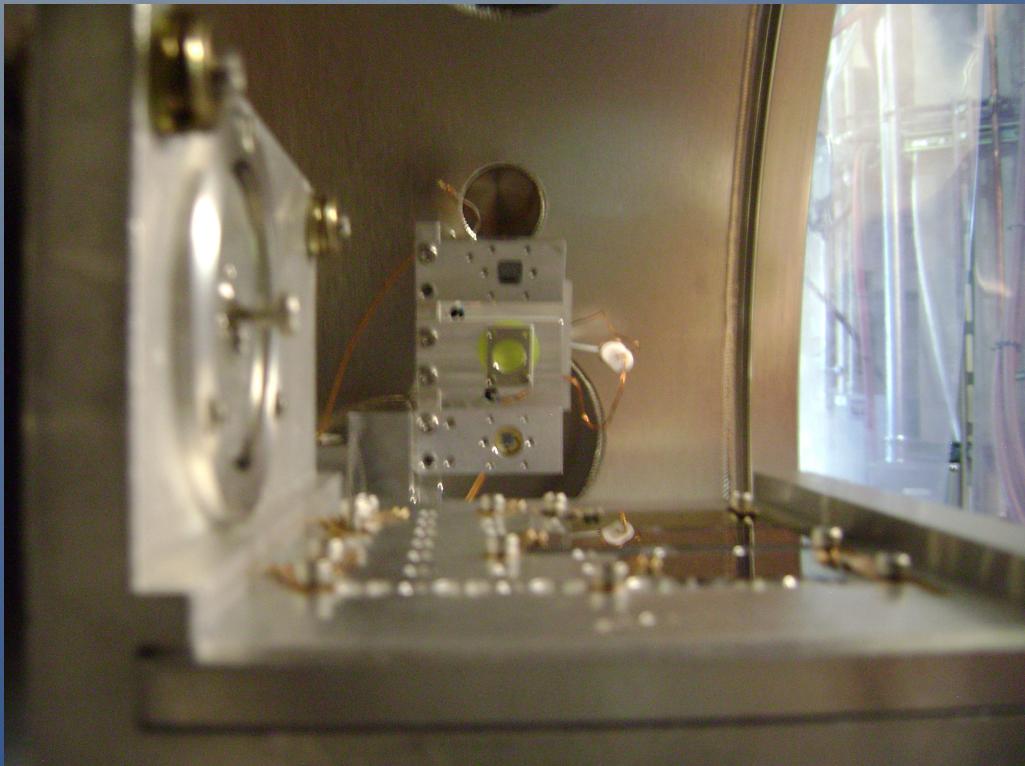
ALS Reflectometer



ALS Reflectometer

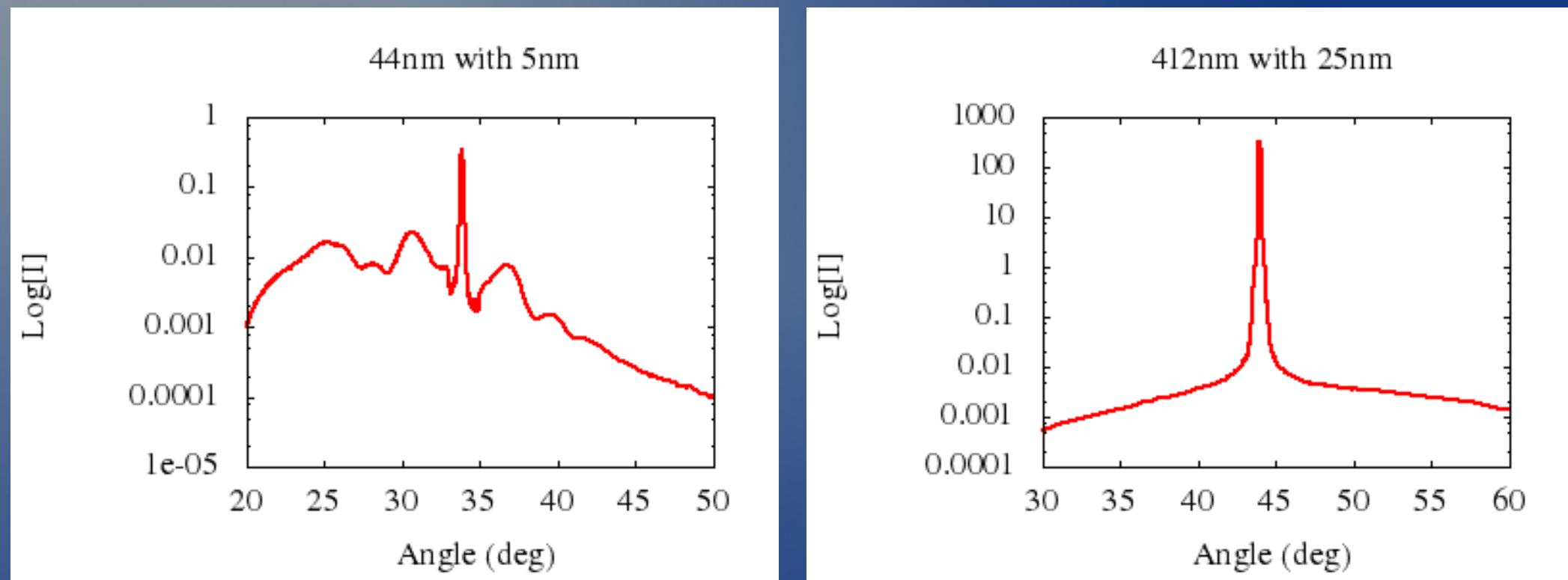


ALS Reflectometer



1. Channeltron
2. Photodiode

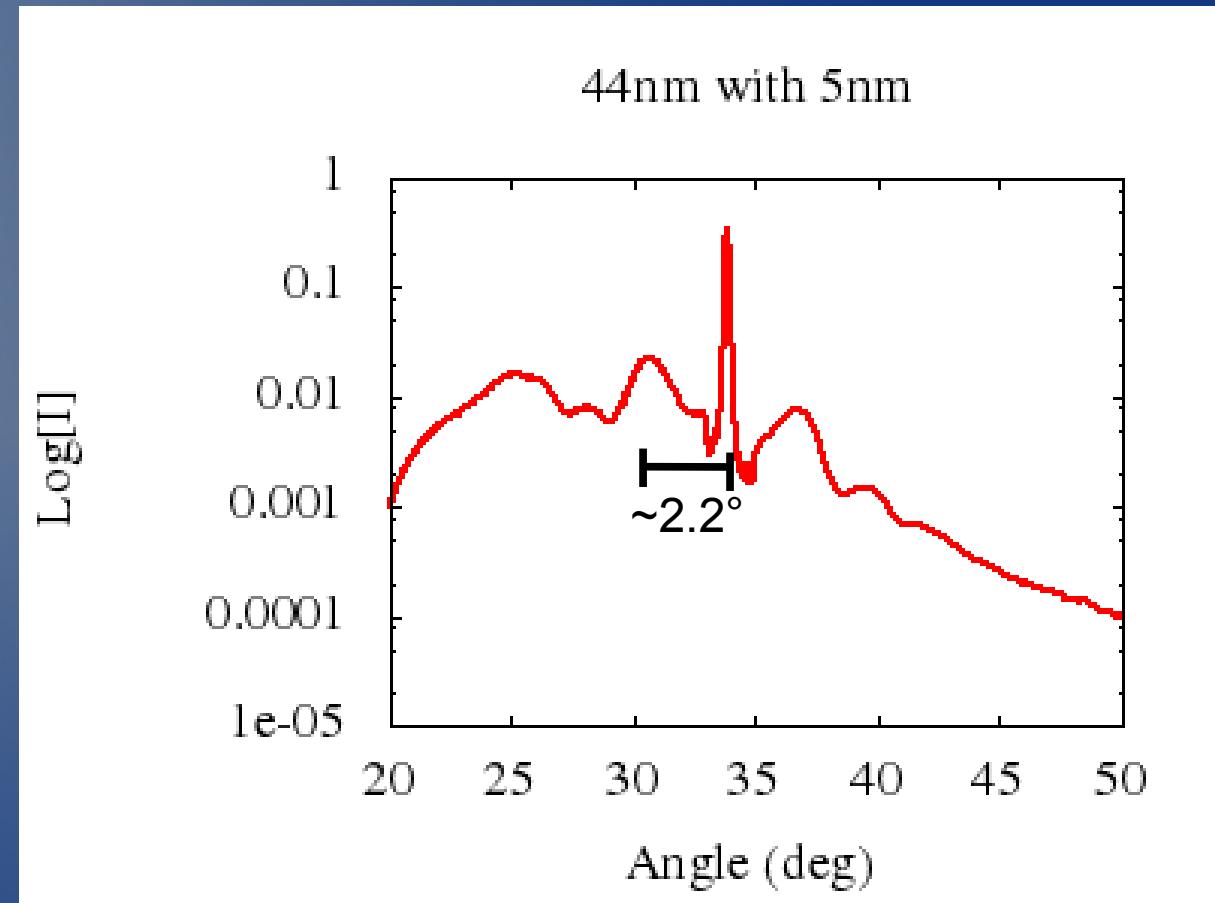
Reflection Results



Diffraction Grating?

- Grating Equation

$$d \sin(\theta) = m\lambda$$

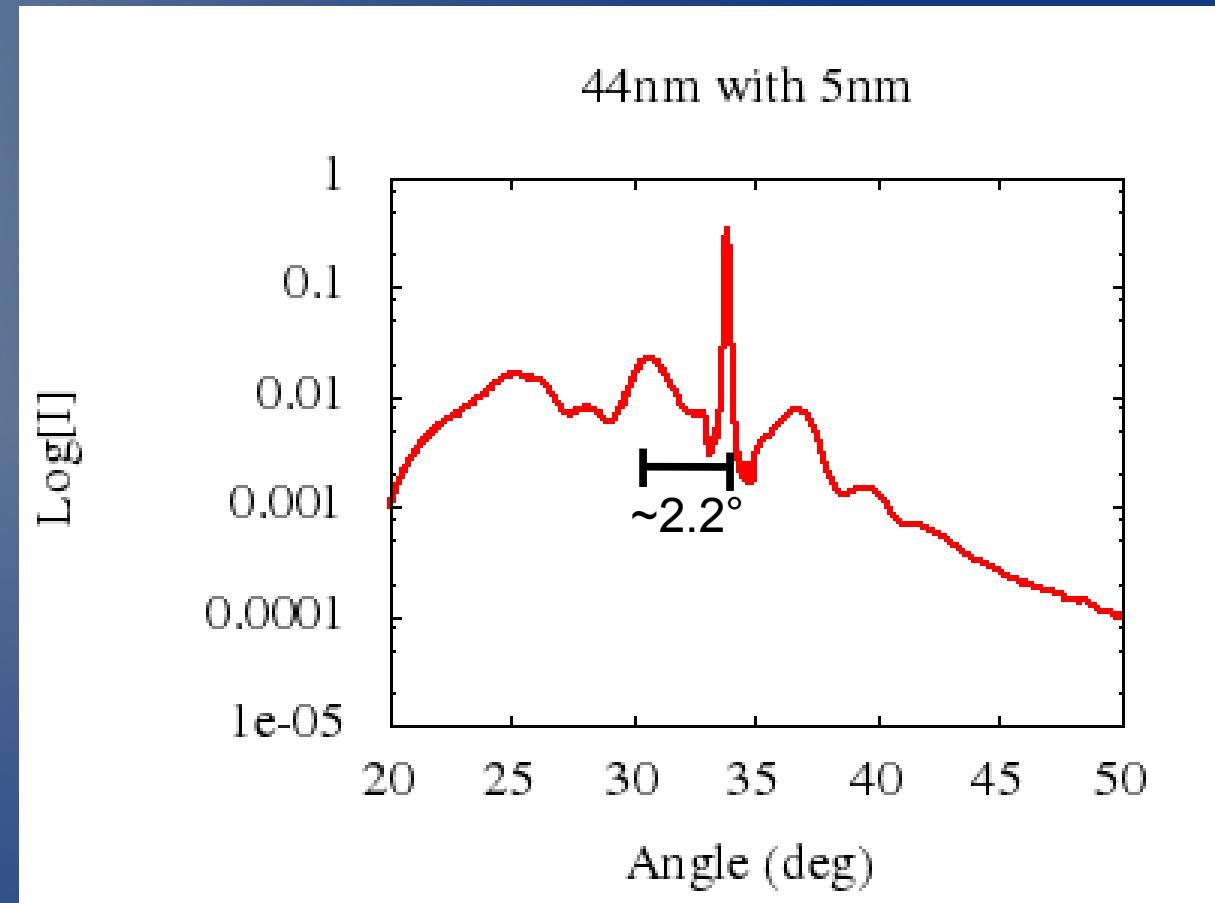


Diffraction Grating?

- Grating Equation

$$d \sin(\theta) = m\lambda$$

$$d \sin(2.2^\circ) = (1)*5\text{nm}$$



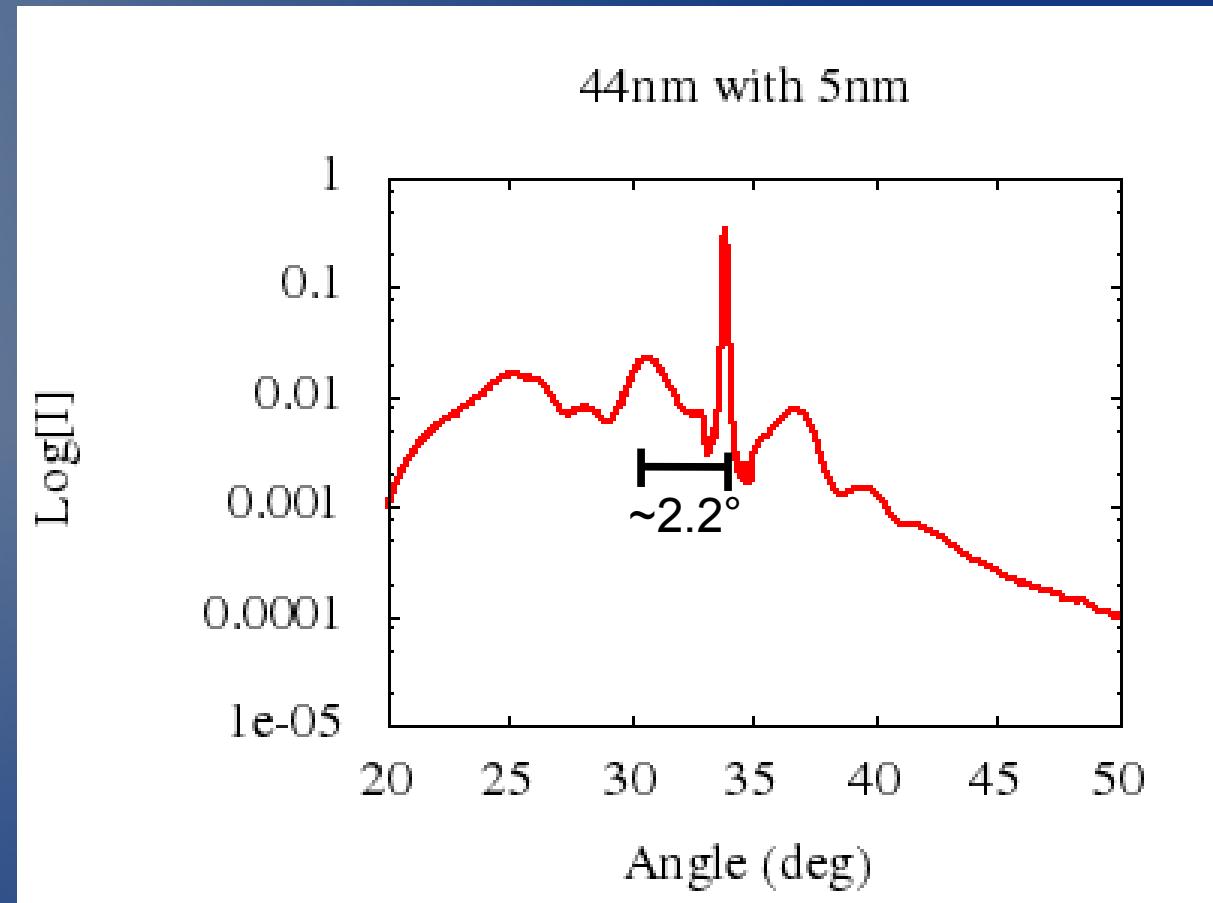
Diffraction Grating?

- Grating Equation

$$d \sin(\theta) = m\lambda$$

$$d \sin(2.2^\circ) = (1) * 5\text{nm}$$

$$d = 0.13\mu m$$



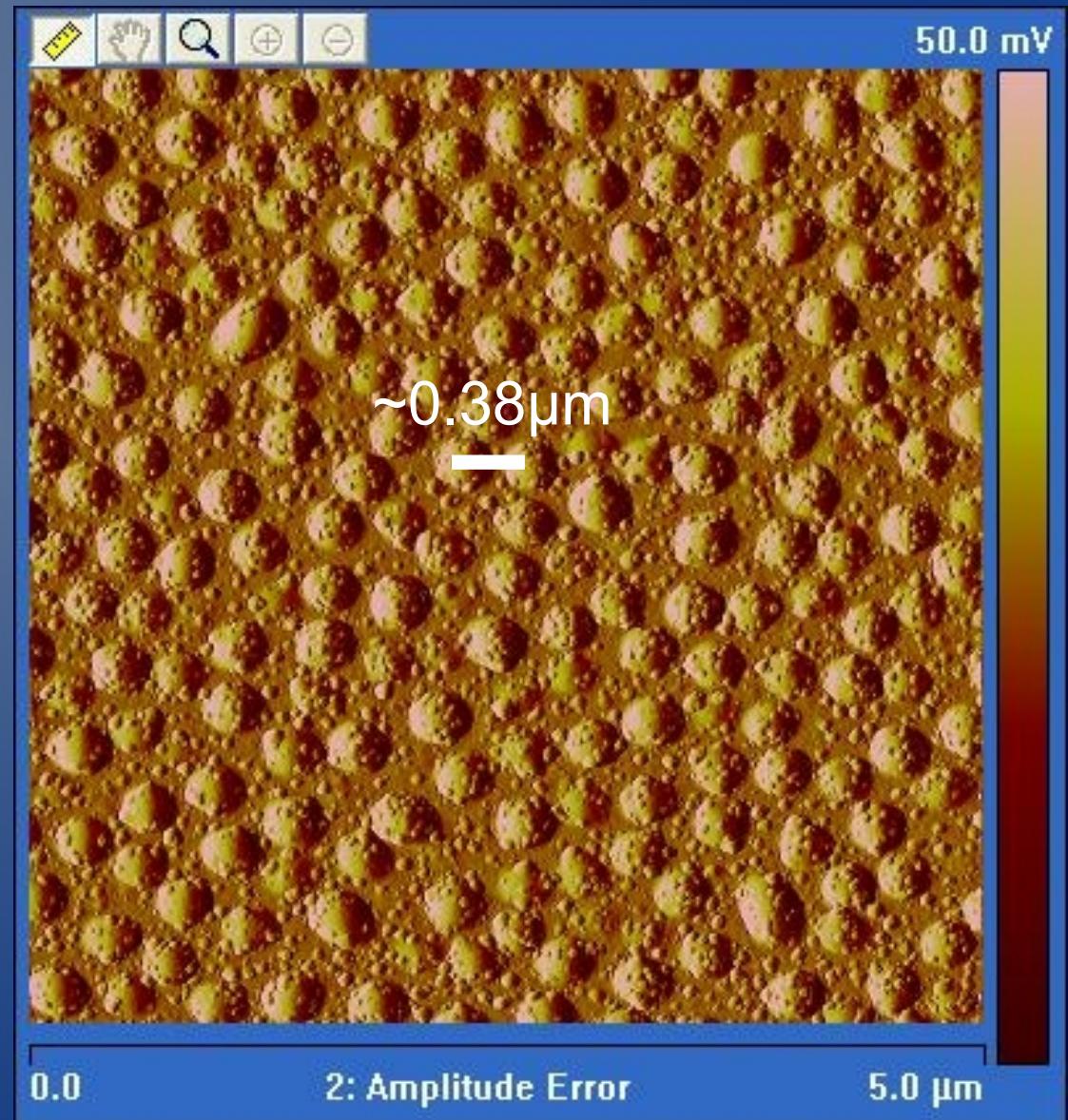
Diffraction Grating?

- Grating Equation

$$d \sin(\theta) = m\lambda$$

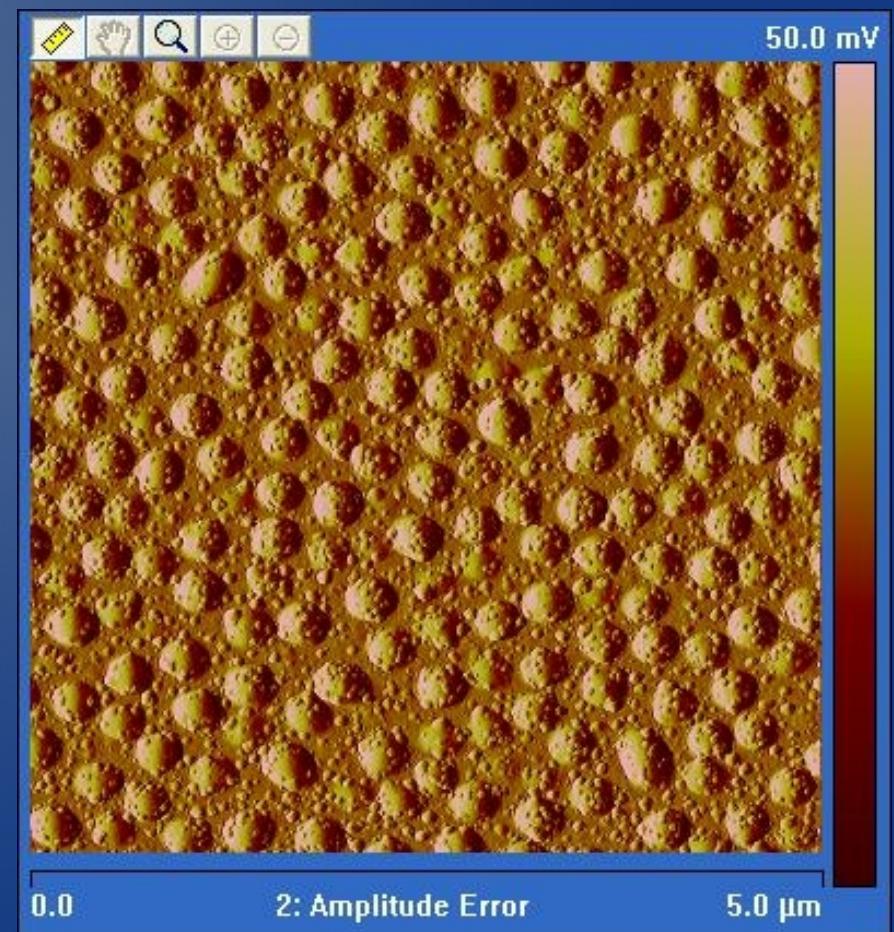
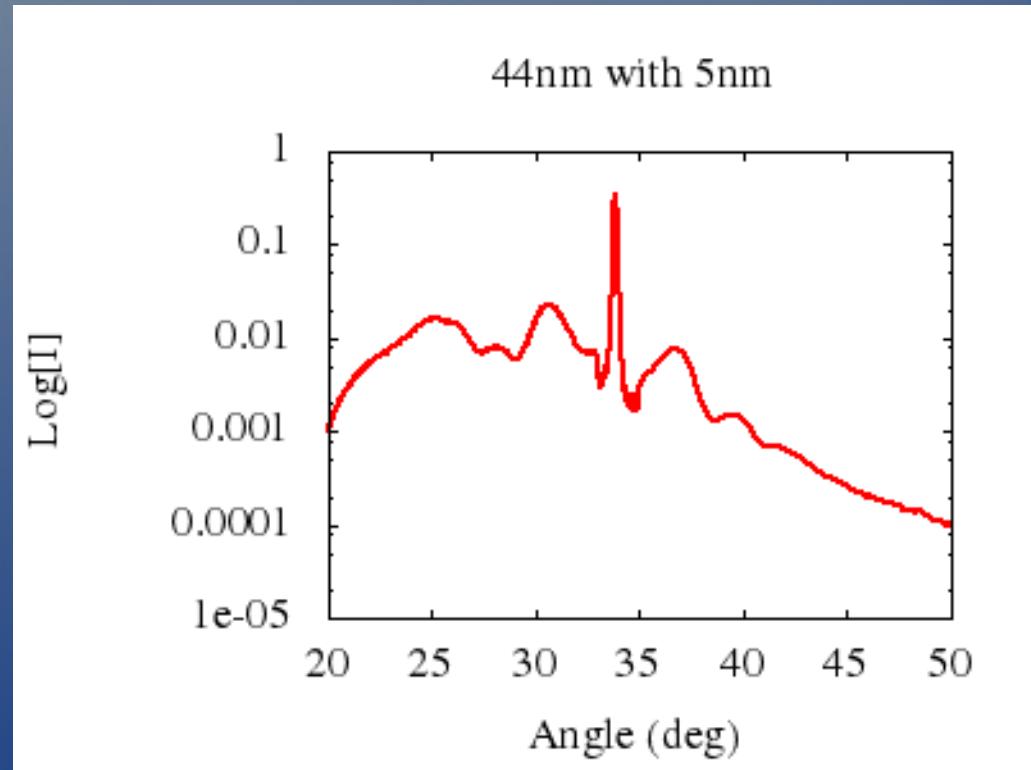
$$d \sin(2.2^\circ) = (1) * 5\text{nm}$$

$$d = 0.13\mu m$$



Conclusion

- From these results we conclude that reflection measurements have the potential to tell us new things about our thin film samples.



Acknowledgements

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- David Allred
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